

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

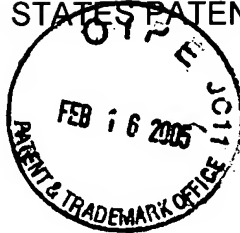
In re Patent Application of:

Hideto OHNUMA

Serial No. 10/053,572

Filed: January 24, 2002

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE



) Group Art Unit: 2812

) Examiner: J. Kennedy

) CERTIFICATE OF MAILING

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) 2005.

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Advisory Action dated January 18, 2005, and further in response to the Final Official Action mailed September 16, 2004, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.